

<b>Notice of References Cited</b>	Application/Control No. 10/726,477	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Amanda C. Walke	Art Unit 1752	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,329,492	12-2001	Sue et al.	528/97
*	B	US-6,713,589	03-2004	Sue et al.	528/97
*	C	US-6,207,789	03-2001	Sue et al.	528/153
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2002014474 A	01-2002	Japan	SATO et al.	
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	English Language machine translation of JP 2002-14474
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.